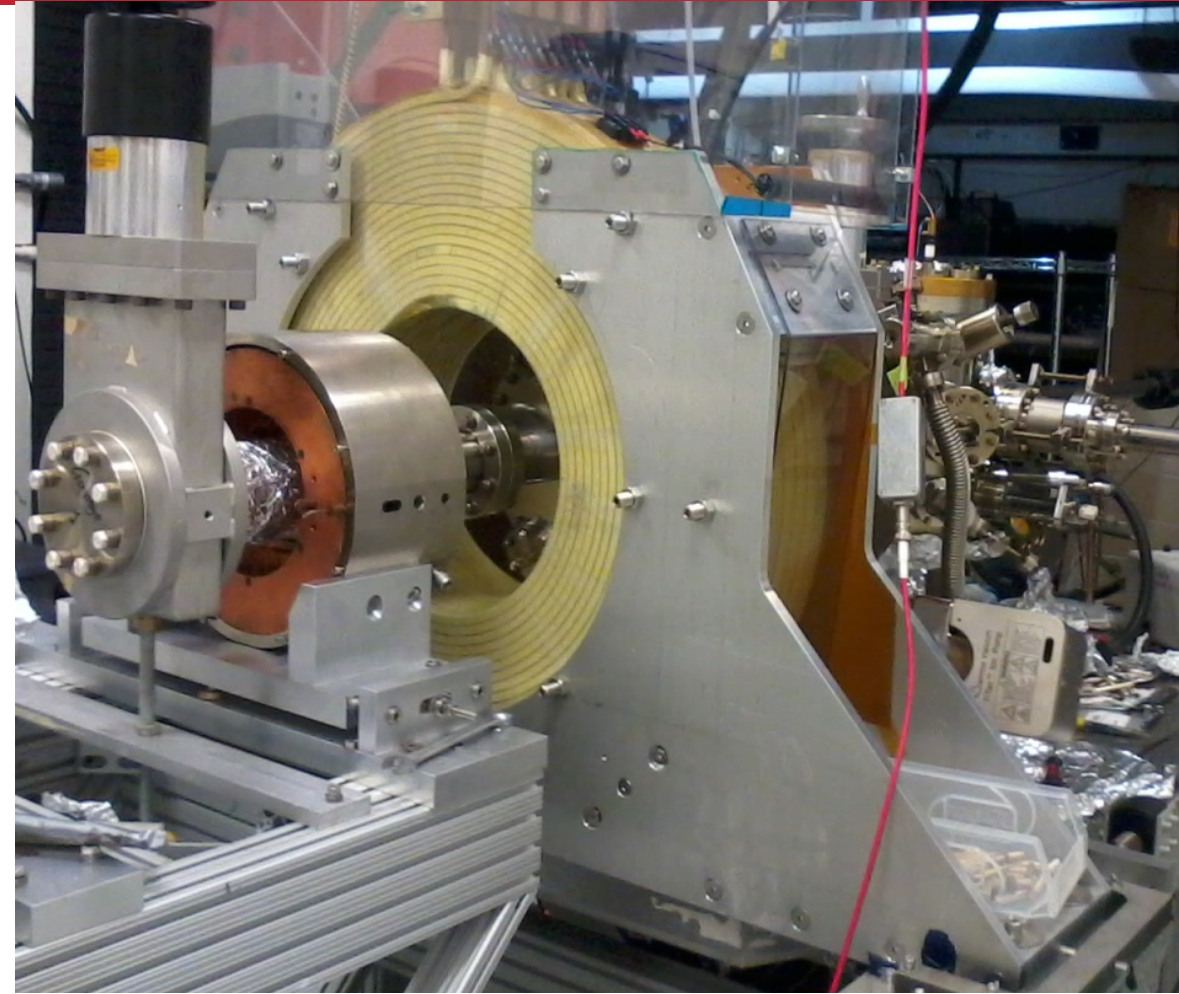


Magnetized beam generated from DC gun for JLEIC Electron Cooler

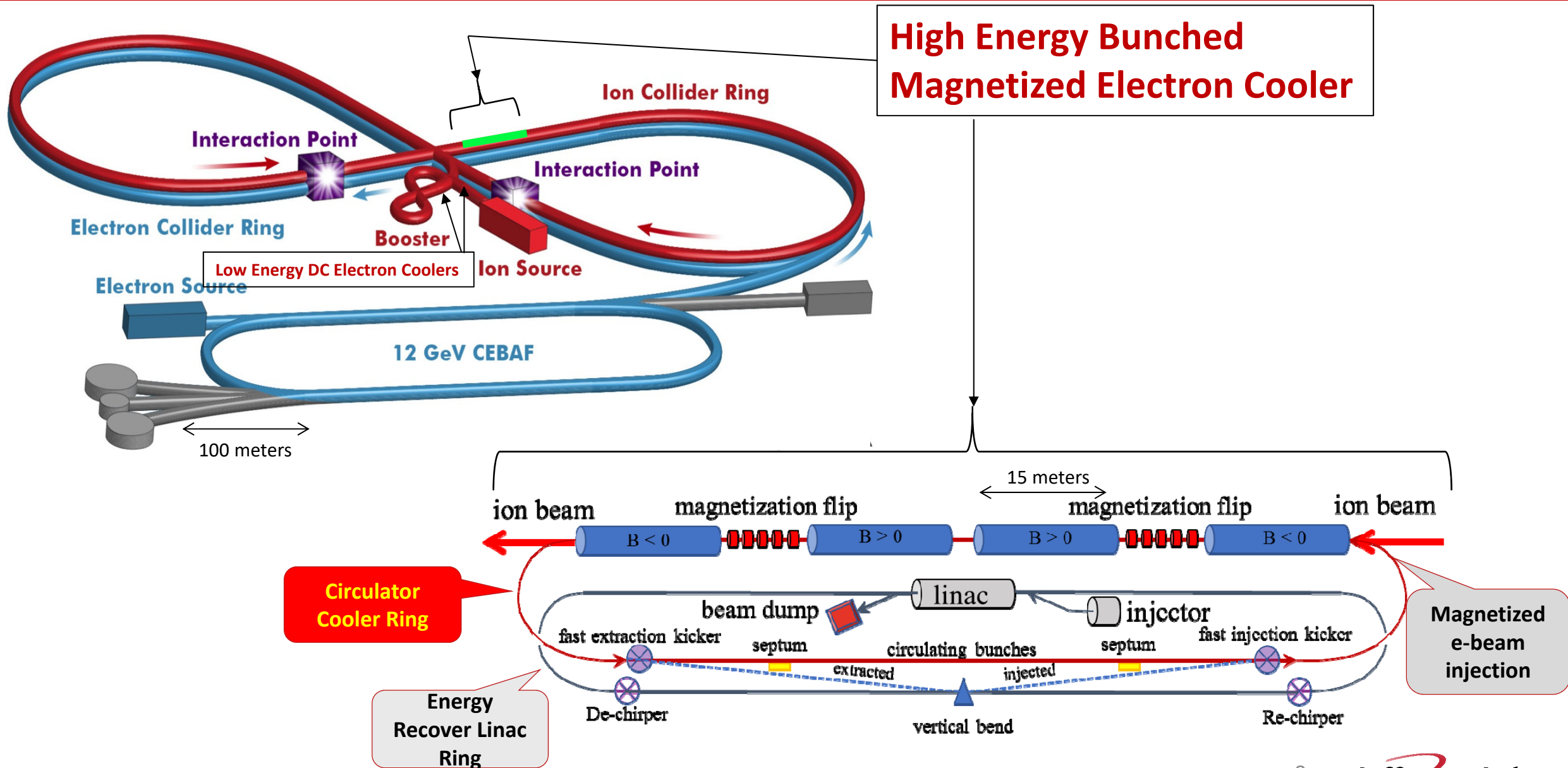
P. Adderley, B. Bullard, J. Benesch,
J. Grames, F. Hannon, J. Hansknecht,
C. Hernandez-Garcia, R. Kazimi, G. A.
Krafft, M. A. Mamun, **G. Palacios-Serrano**,
M. Poelker, M. Stutzman, R. Suleiman,
M. Tiefenback, C.A. Valerio Lizarraga,
Y. Wang, **S. Wijethunga**, **J. Yoskowitz** and
S. Zhang.

Graduate students, Old Dominion University



Supported in part by DoE and JLab LDRD

The proposed JLEIC High Energy Electron Cooler is based on magnetized bunched electron beam generated in an Energy Recover Linac

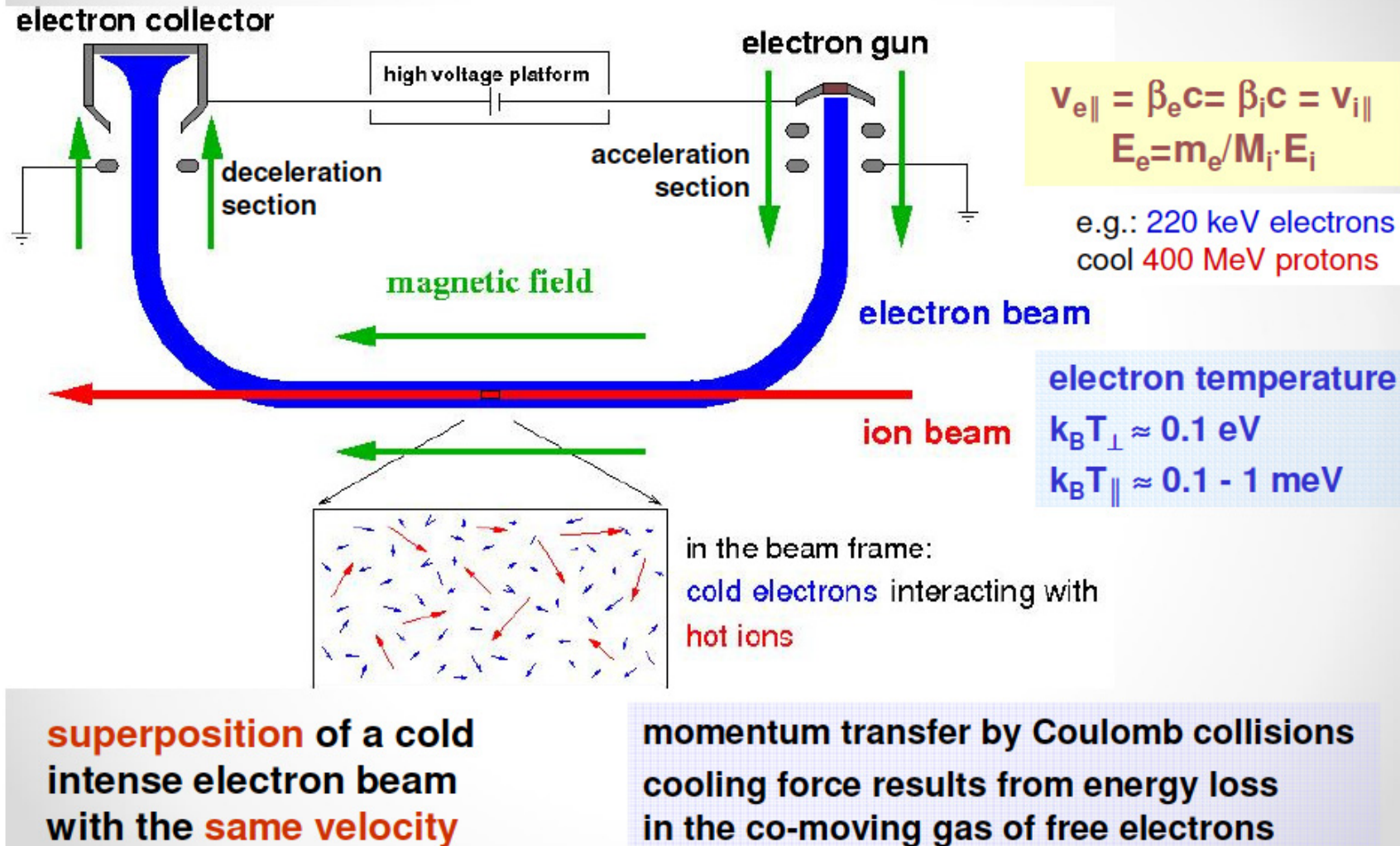


Magnetized bunched-beam electron cooling of the ion beam

- Ion beam cooling in the presence of a solenoid field is much more efficient than cooling in a drift (no magnetic field):
 - Electron beam helical motion in strong magnetic field increases electron-ion interaction time, thereby significantly improving cooling efficiency
 - Electron-ion collisions that occur over many cyclotron oscillations and at distances larger than cyclotron radius are less sensitive to electrons transverse velocity
 - However, using an SRF linac to accelerate the electrons implies a discontinuous solenoid field.
- Long cooling solenoid provides strong hadron cooling:
 - Counteracting emittance degradation induced by intra-beam scattering
 - Maintaining ion beam emittance during collisions and extending luminosity lifetime
 - The spin effects of the solenoid must be compensated.

Incoherent Electron Cooling

1. Electron Cooling

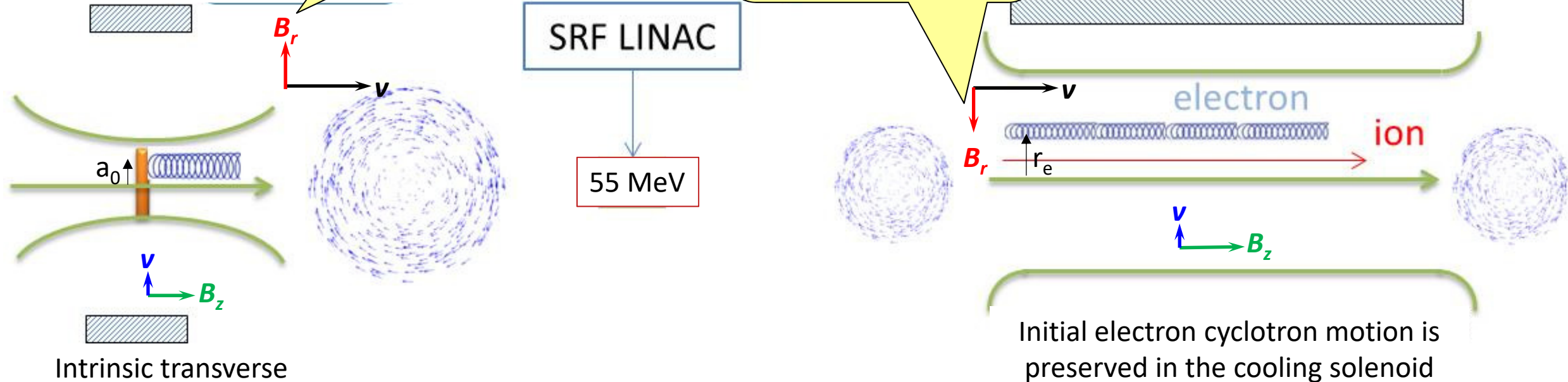


Magnetized cooling schematics

Electrons are generated in the strong uniform B_z of the cathode solenoid

Mechanical angular momentum $\langle L \rangle$ is imparted to the e-beam when leaving the cathode solenoid field

Mechanical angular momentum $\langle L \rangle$ is removed from the e-beam upon entering the cooling solenoid field



Intrinsic transverse momentum of electrons at photocathode translates into cyclotron motion

$$\langle L \rangle = \frac{eB_z a_0^2}{4}$$

$$\frac{B_{cool}}{B_z} = \frac{a_0^2}{r_e^2}$$

$$\langle L \rangle = \frac{eB_{cool} r_e^2}{4}$$

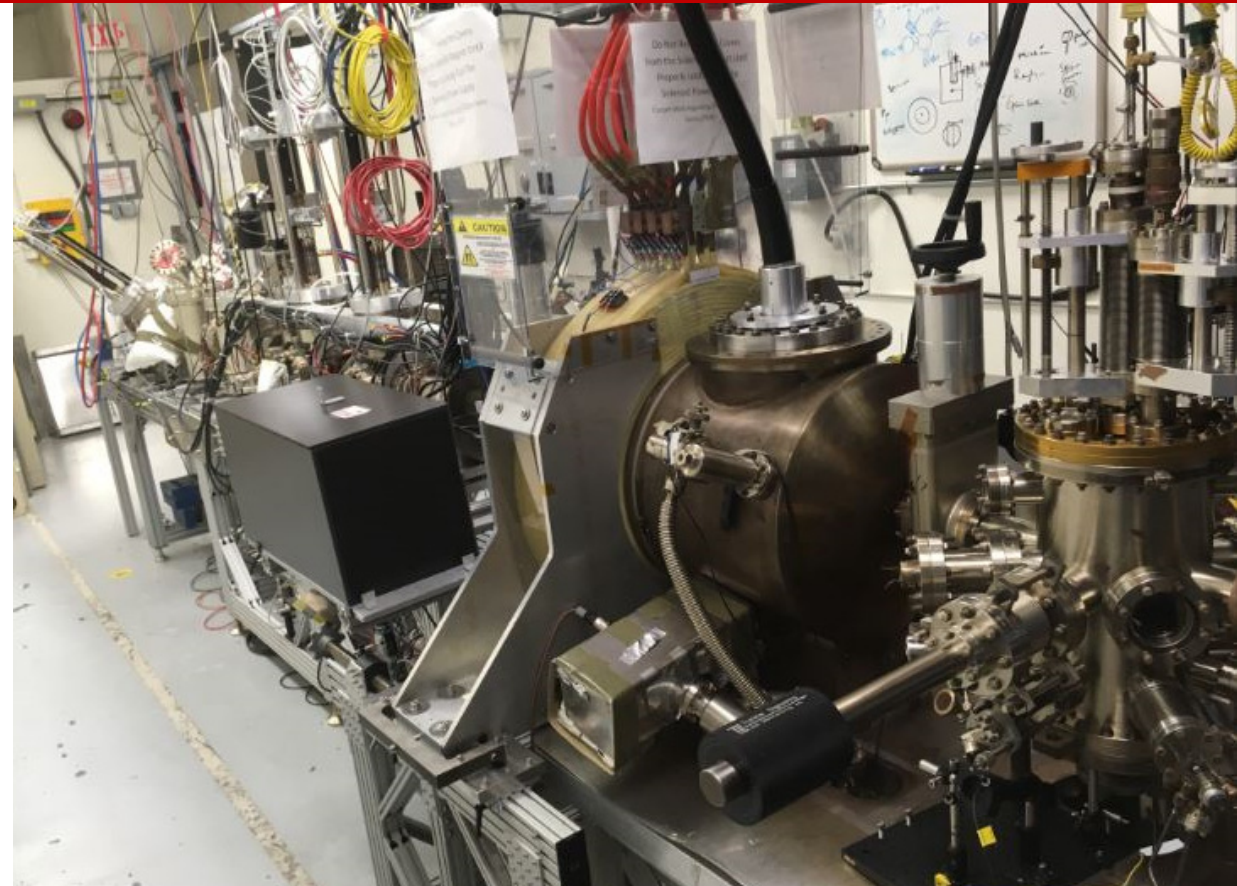
JLEIC magnetized source beam requirements

Parameter	Magnetized Source Parameters
Electron bunch length	100 ps (3 cm) Flat-top at cooler injection
Repetition rate	43.3 MHz
Bunch charge	3.2 nC
Peak current	32 A
Average current	140 mA
Transverse normalized (Larmor) emittance	<10 microns
Normalized drift emittance	36 microns (@ 3.2 nC)
Cathode spot radius – Flat-top (a_0)	3.14 mm
Solenoid field at cathode (B_z)	0.50 kG

**World record is 65 mA
CW, non-magnetized
(Dunham et al., Appl. Phys.
Lett. 102 (2013) 034105)**

The JLab magnetized source test stand is utilized to develop the technology for achieving the JLEIC magnetized source requirements

- Prototype magnetized source was funded by the Jefferson Lab LDRD program that aimed to operate up to 30 mA average current. This three-year project concluded in October 2018
- Goals of the project:
 - Generate magnetized bunched electron beam from dc high voltage photogun and measure its properties
 - Explore impact of cathode solenoid on photogun operation
 - Perform simulations and measurements to provide insights on ways to optimize JLEIC electron cooler and help design appropriate source
 - Provide JLab with direct experience on magnetizing electron beams at high current

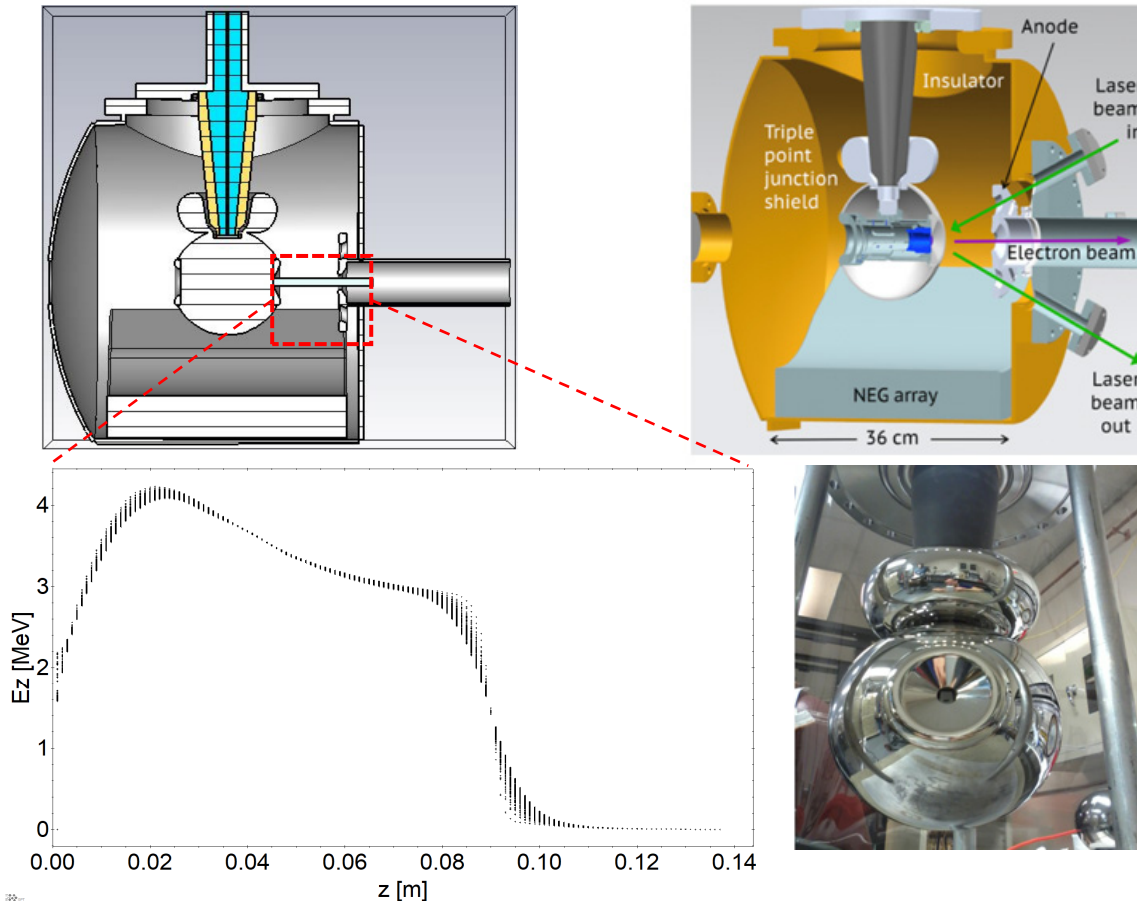


- Gun high voltage: 100 – 300 kV
- Average beam currents up to 30 mA CW
- Laser spot size at cathode $a_0 = 0.1 - 1.0$ mm (rms)
- Laser pulse length: 50 ps FWHM
- Laser wavelength 532 nm
- Laser operating frequency: 1-15 Hz , or 100-500 MHz
- Longitudinal magnetic field at cathode $B_z = 0 - 1.5$ kG
- Target Bunch charge: 3 nC

The magnetized source consists of a 300 kV inverted electron gun with K_xCs_ySb photocathode and a cathode solenoid magnetization coil

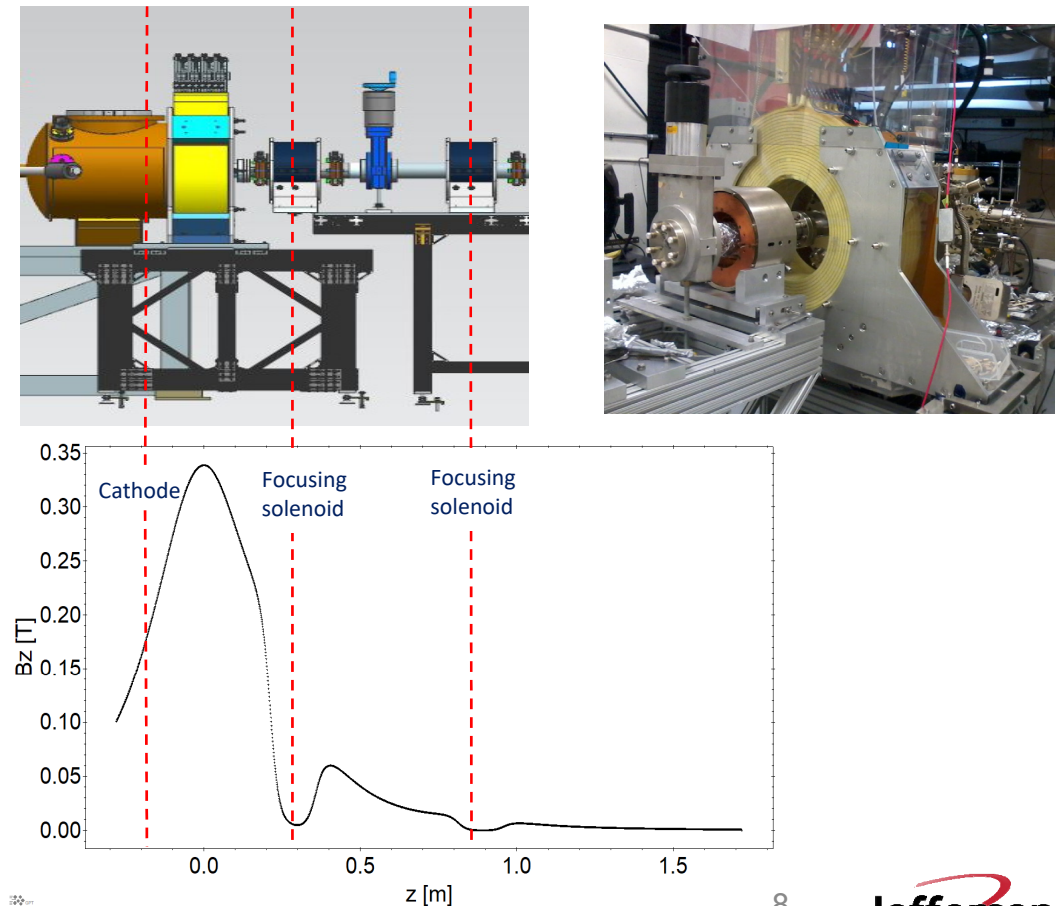
Gun high voltage chamber:

- Based on alumina inverted insulator and triple junction shield for max gradient of 10 MV/m at 350 kV
- High voltage conditioned to 360 kV in 70 hours
- Nominal vacuum levels $\sim 5 \times 10^{-12}$ Torr after vacuum bake and high voltage conditioning for 300 kV operation

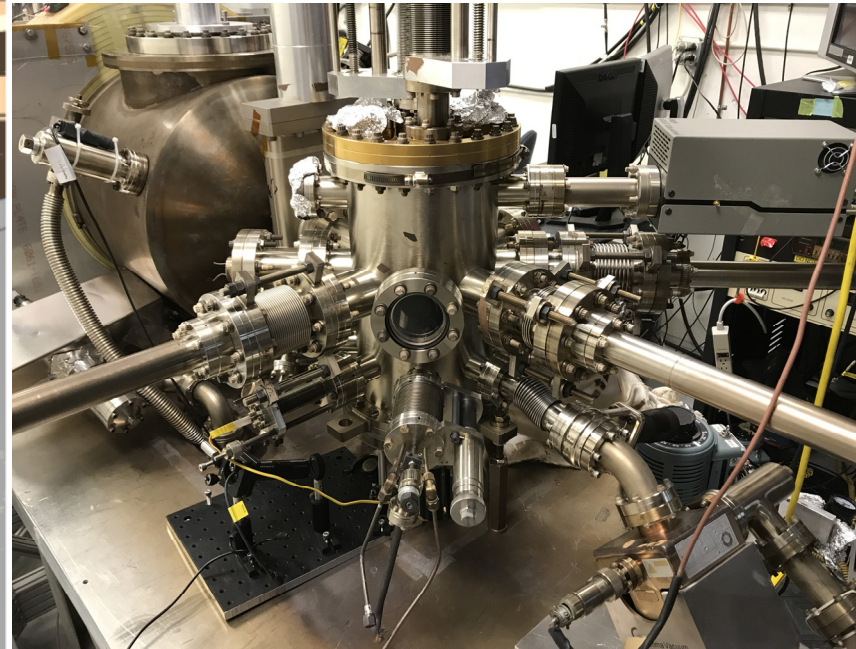
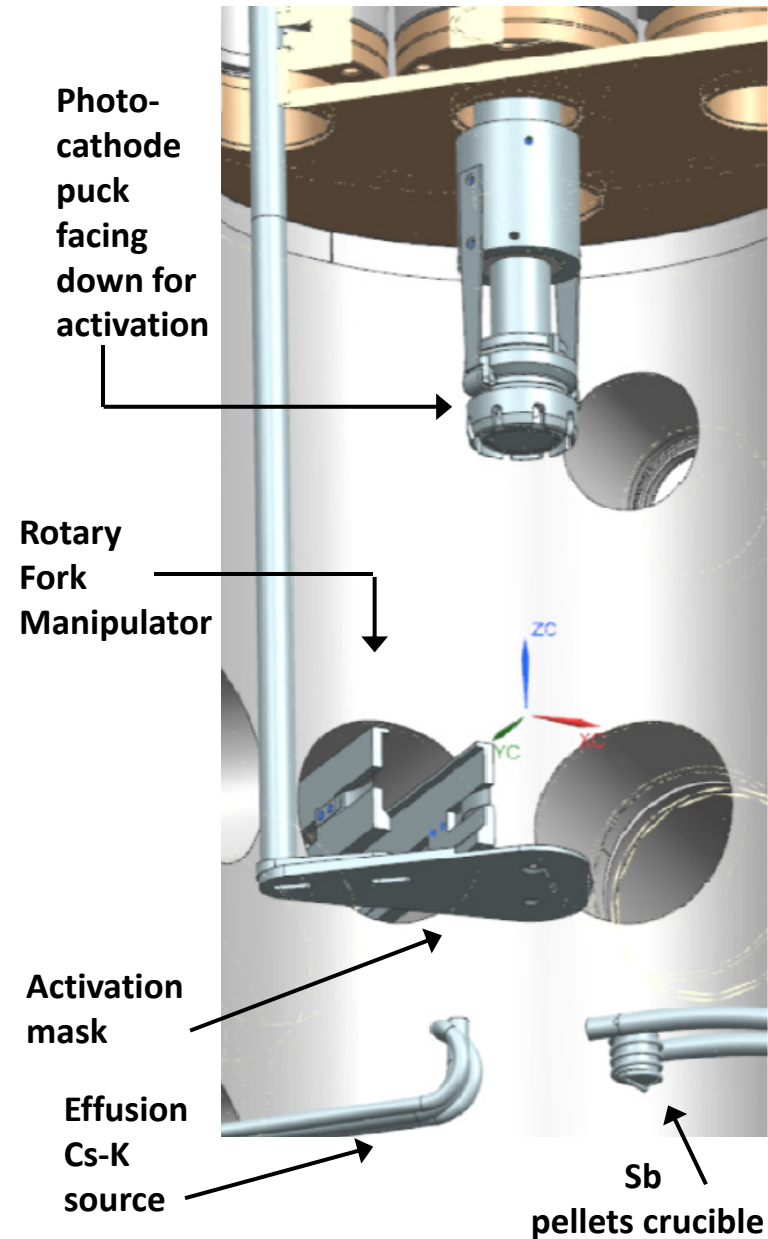


Cathode Solenoid:

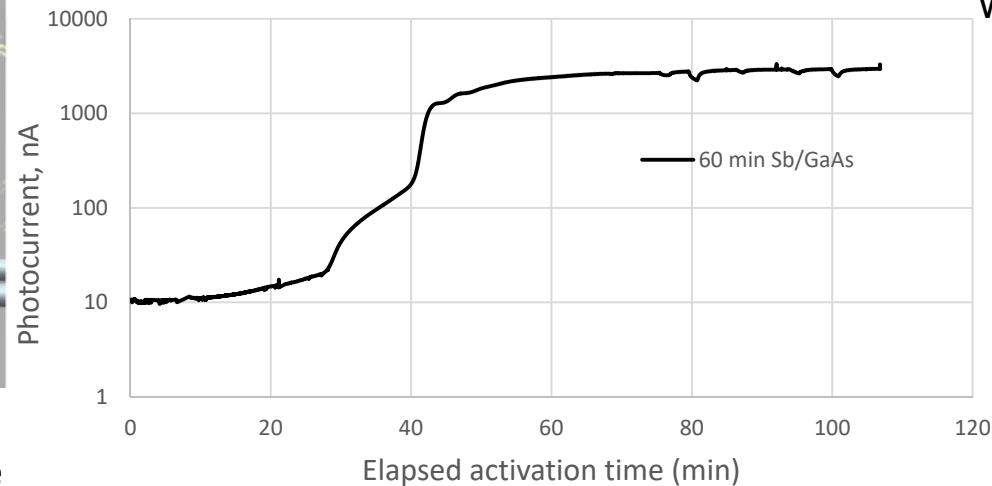
- Located 0.2 m away from the cathode.
- Provides 1.5 kG to the cathode for a maximum of 400 A.
- Field map is distorted due to the shield covers of the neighboring focusing solenoids.



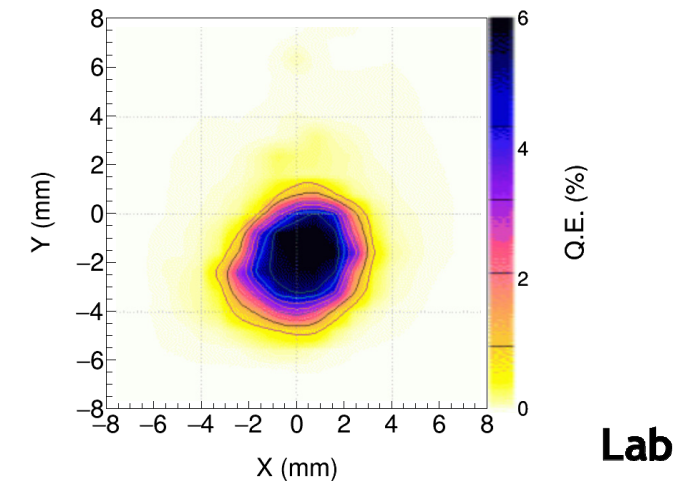
K_xCs_ySb photocathode films are grown on substrates in a vacuum chamber connected to the photogun



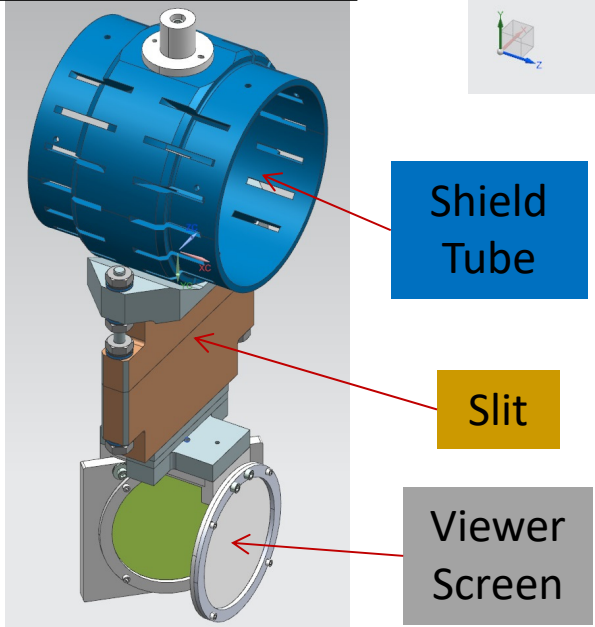
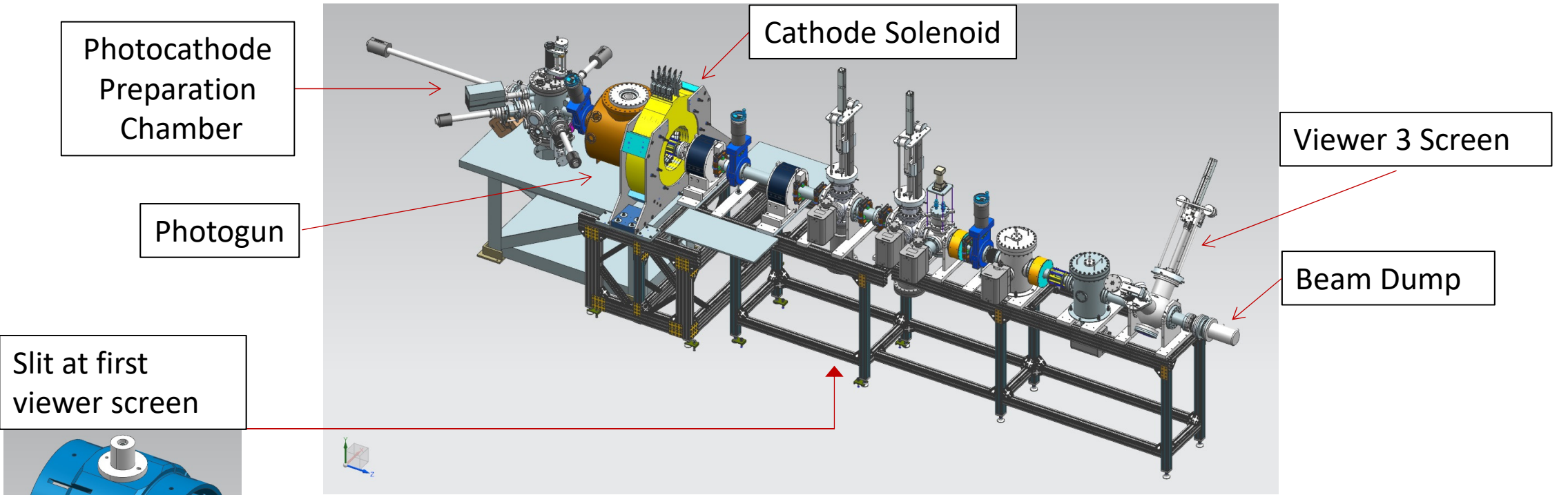
Bi-alkali activation on GaAs substrate



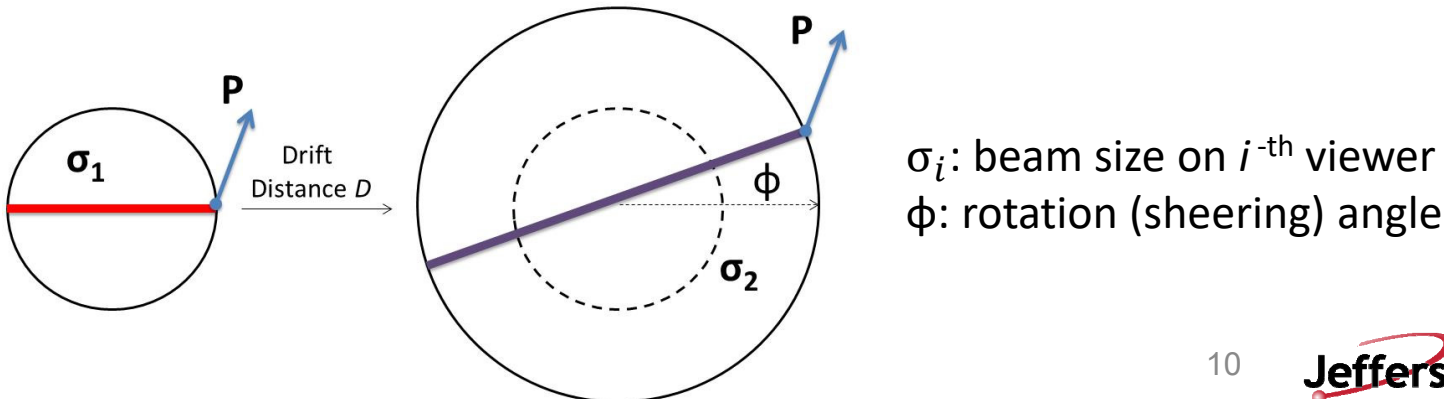
- K_xCs_ySb grown with a mask – limit photocathode active area (3 and 5 mm diameter) to reduce beam halo and prolong quantum efficiency operating lifetime
- Active area can be offset from electrostatic center to minimize damaging on the emission area from ion back bombardment and micro-arcing events during high current run
- **Moly substrate** to reduce laser induced thermal desorption of chemicals during high current run
- Consistently fabricated photocathodes with ~5% QE



A diagnostic beamline for magnetized electron beam source characterization



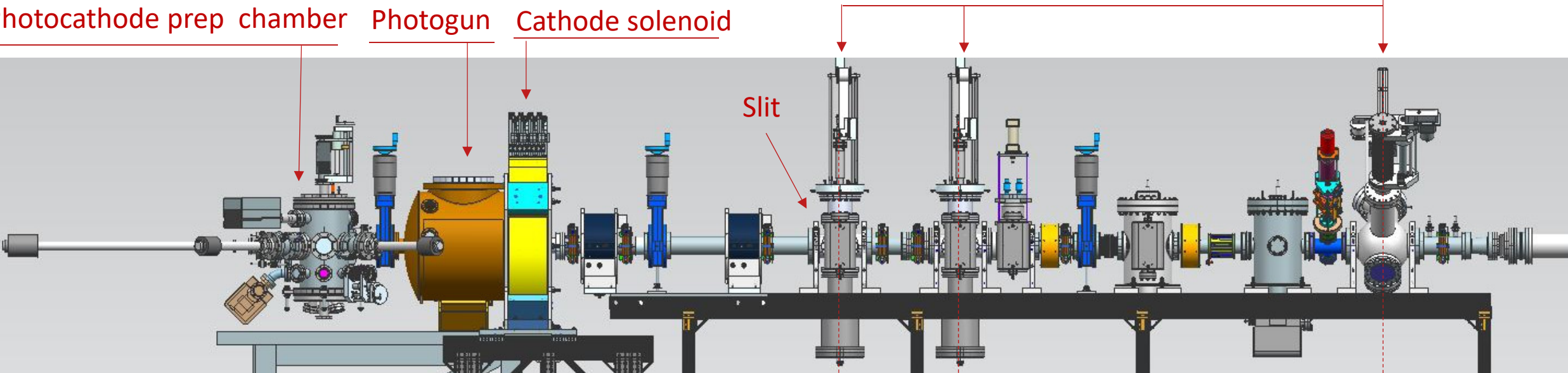
The slit crops the magnetized beam into a beamlette that appears rotated when imaged in a downstream viewer screen



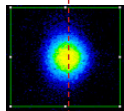
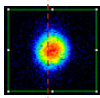
Magnetized beam characterization

Beam and beamlet are observed on viewer YAG screens

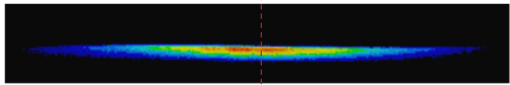
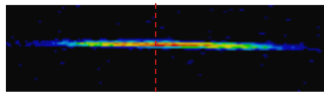
Photocathode prep chamber Photogun Cathode solenoid



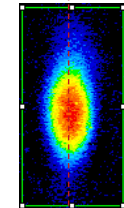
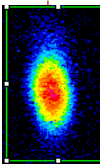
No slit



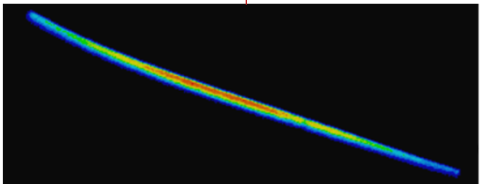
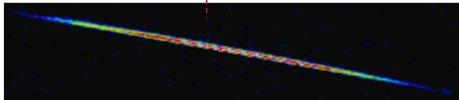
Through slit



No slit



Through slit



Magnetic field at photocathode = 0 G

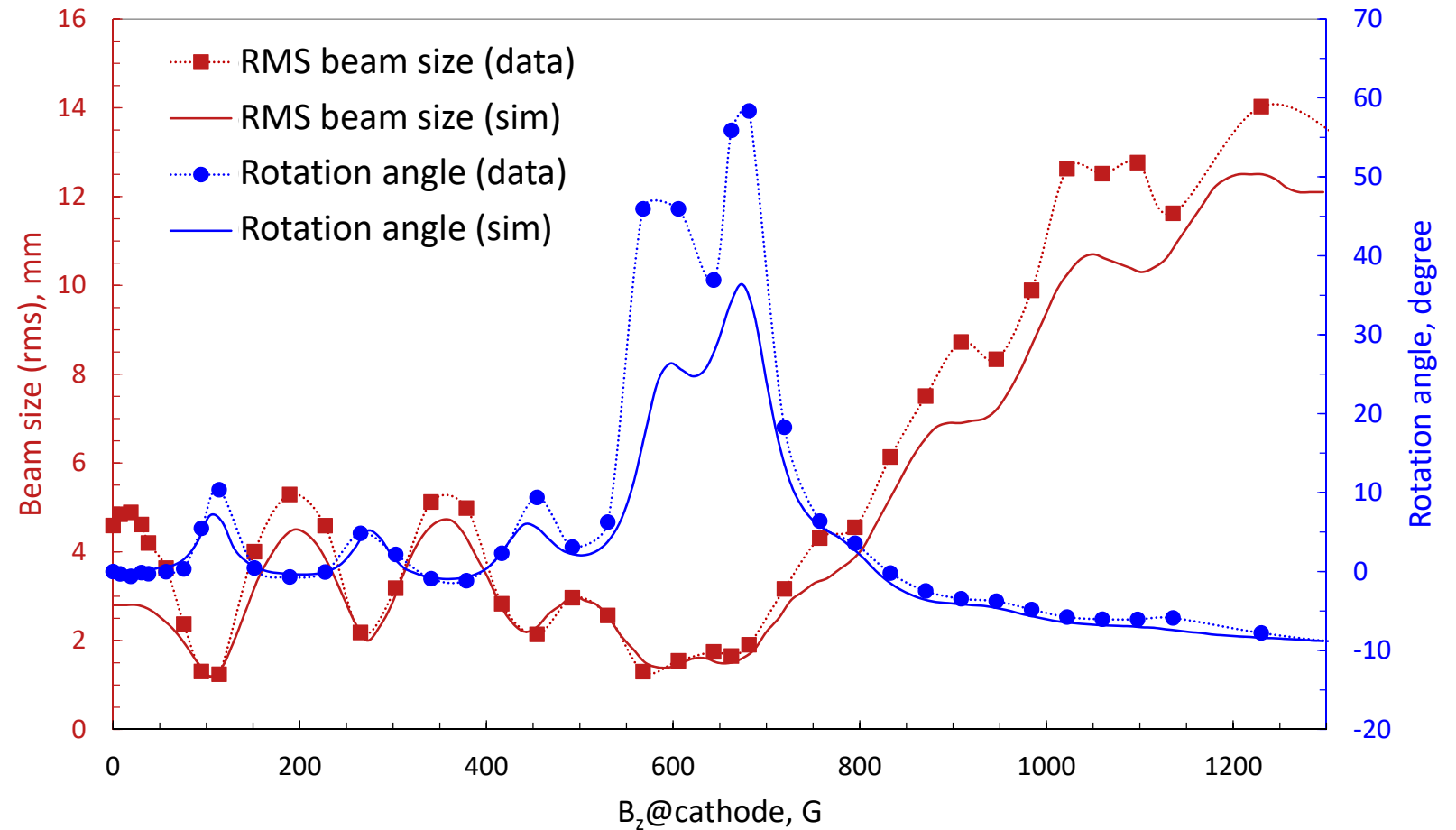
Magnetic field at photocathode = 1514 G

Characterizing beam magnetization

Beam size and Rotation: Experiment vs ASTRA simulation

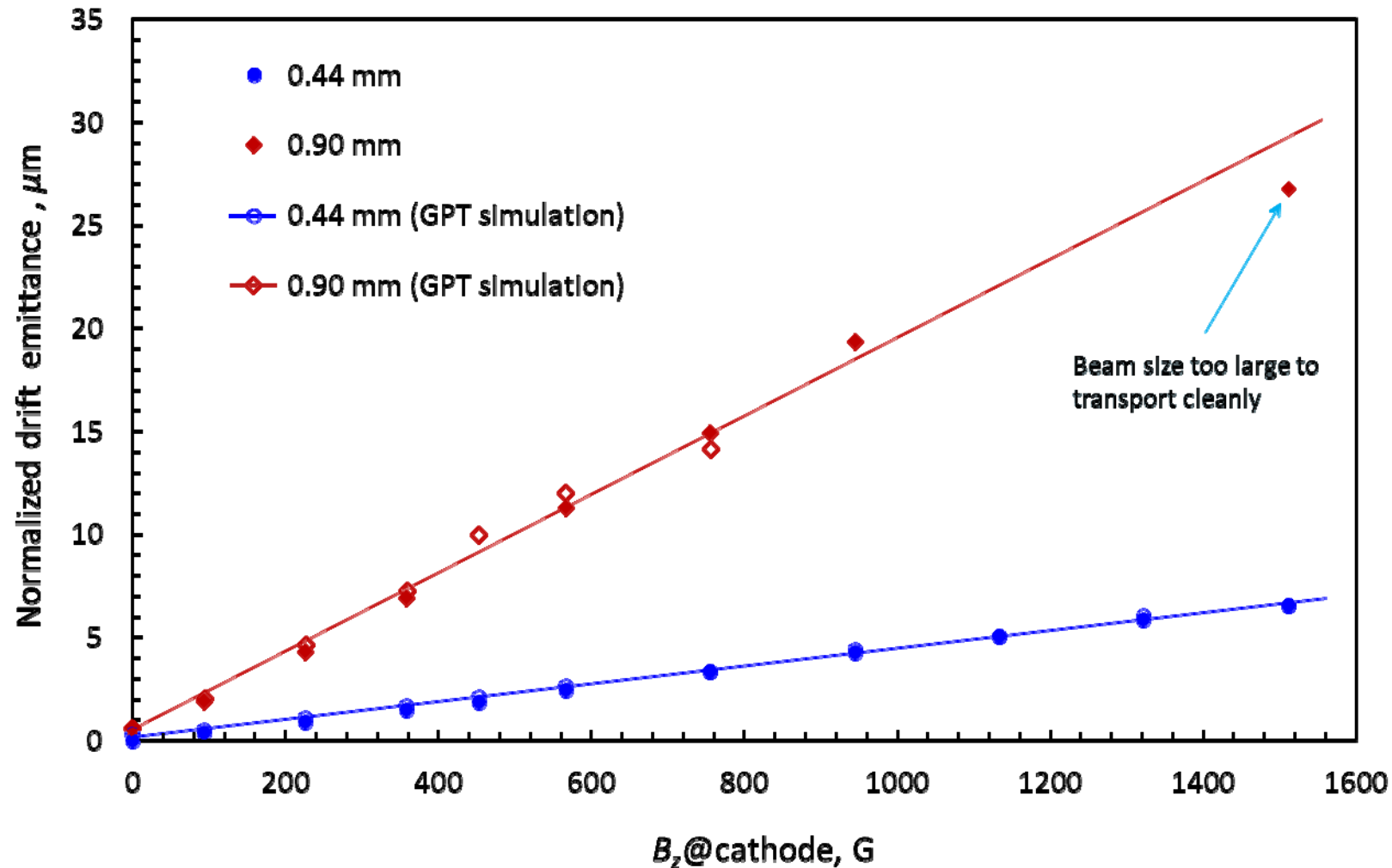
- A non-uniform cathode magnetic field causes mismatch oscillations
- repeated focusing inside the solenoid field affects the beam size at the exit of the solenoid field
- resulting in varying beam expansion rate in the field free region.

Gun voltage 300 kV and laser spot size 0.2 mm rms on photocathode center



Observed and simulated oscillating beam profiles and corresponding beam rotation

Magnetized beam emittance measurements for two laser spot sizes at 200kV



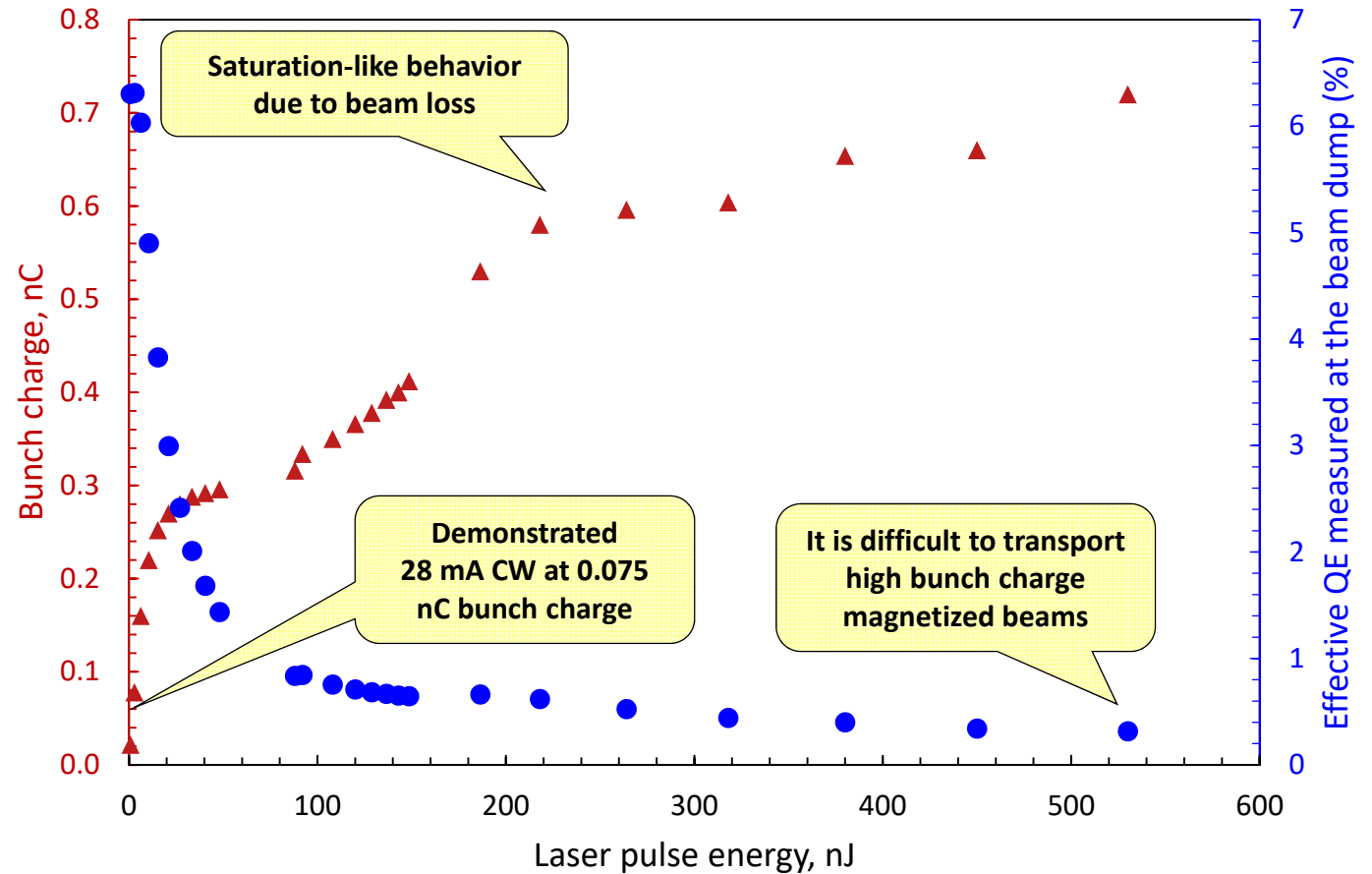
20 femto-Coulomb
bunch charge

GPT simulations and experimental results with 20 femto-Coulomb bunch charge show encouraging agreement between the laser spot size and magnetic field at the photocathode

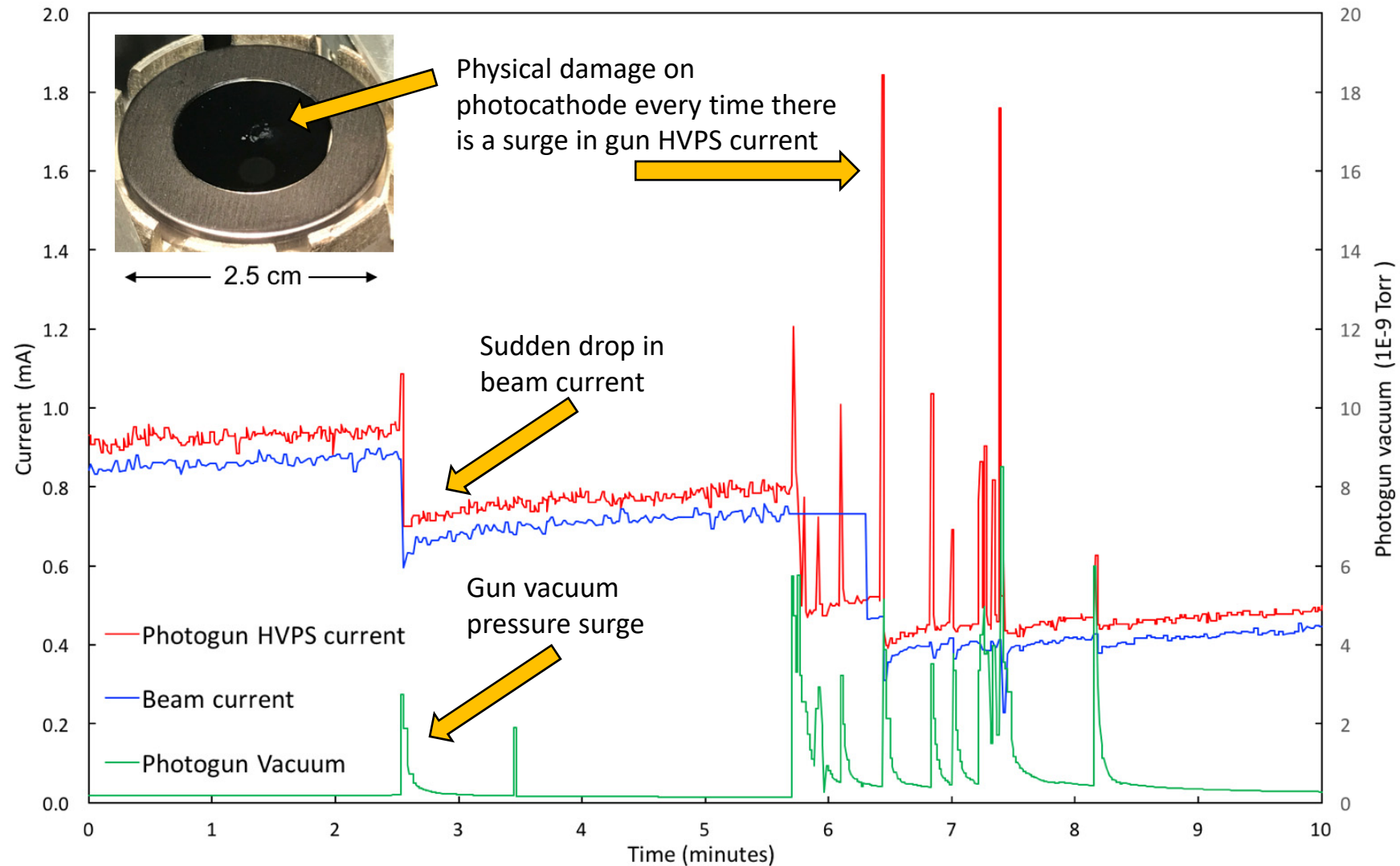
Magnetized beam bunch charge measurements vs. laser pulse energy

- A maximum of ~ 14 nC extractable charge at the photocathode for available laser power (QE%=6.3, $P=2.65 \times 10^{-2}$ W, $f = 50$ kHz)
- Observed an exponential decay in effective QE% with the measured charge at the beam dump
- We encountered space-charge-limited regime within 0.3 nC for different magnetized conditions
- Beam scraping due to limited beamline aperture and insufficient strength of focusing solenoids restricted clean beam transport to the dump for pulse energy >70 nJ
- Need longer laser pulses, higher gun voltage and better beamline optics to get nC bunches

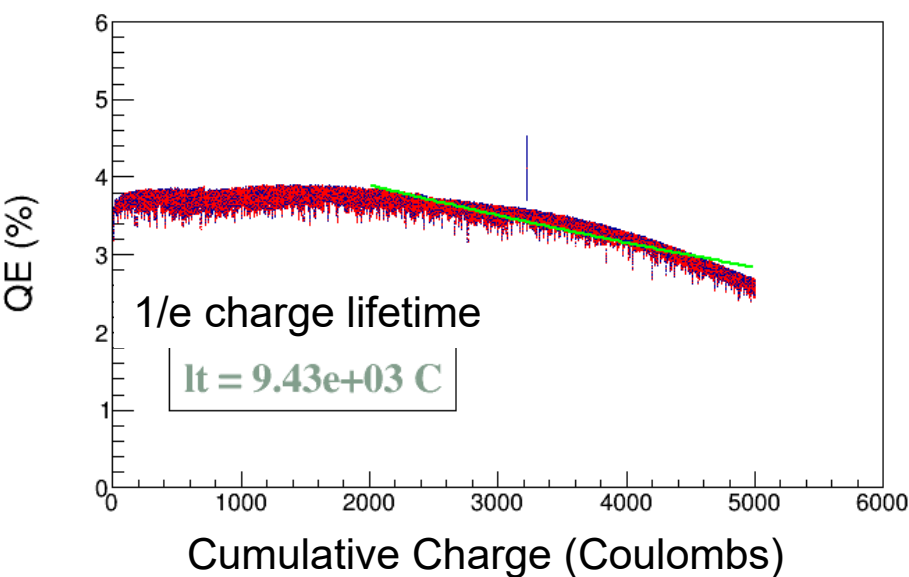
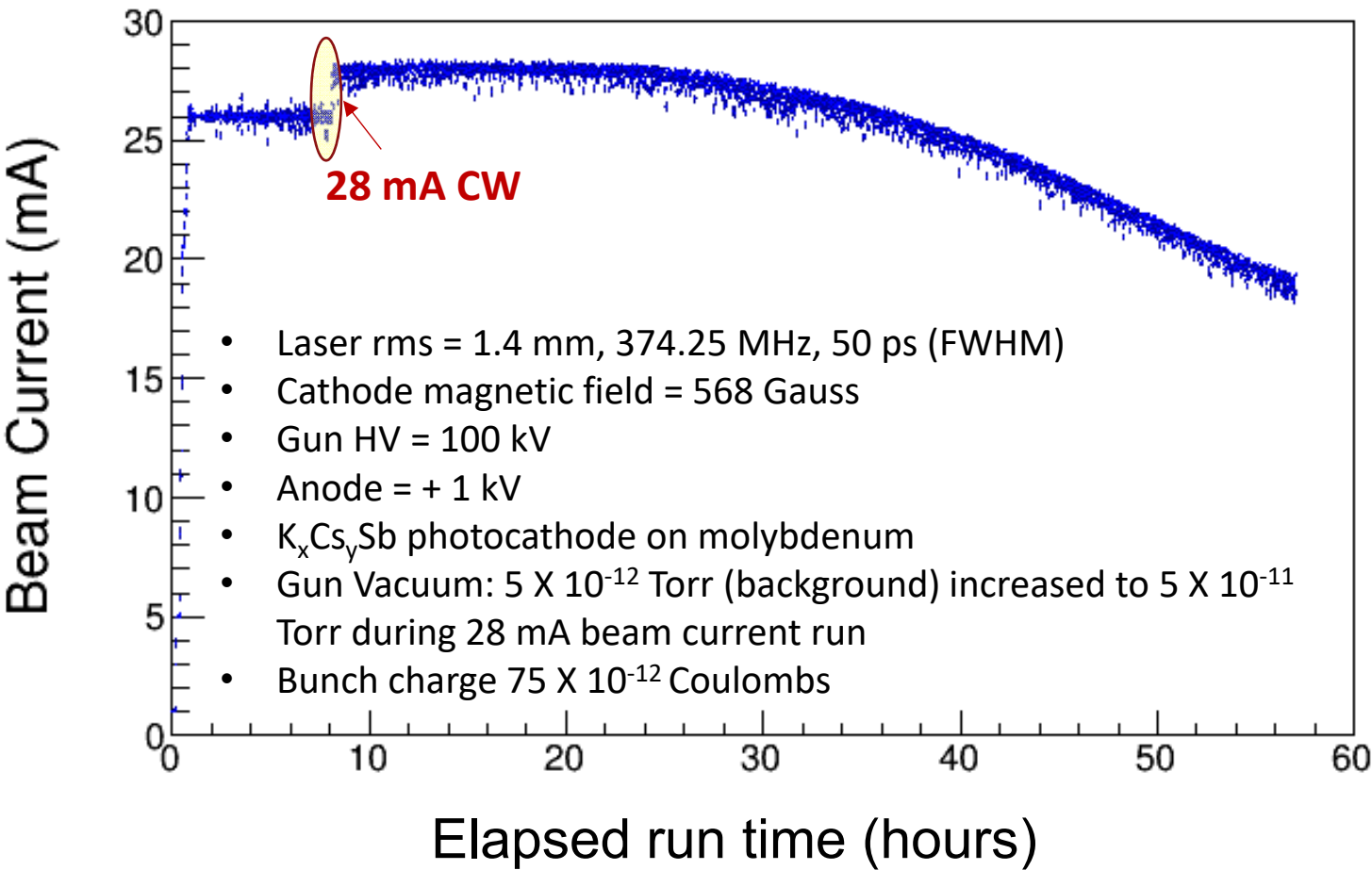
Gun voltage 225 kV, Magnetic field at cathode 757 G, Laser pulse width 75ps (FWHM)



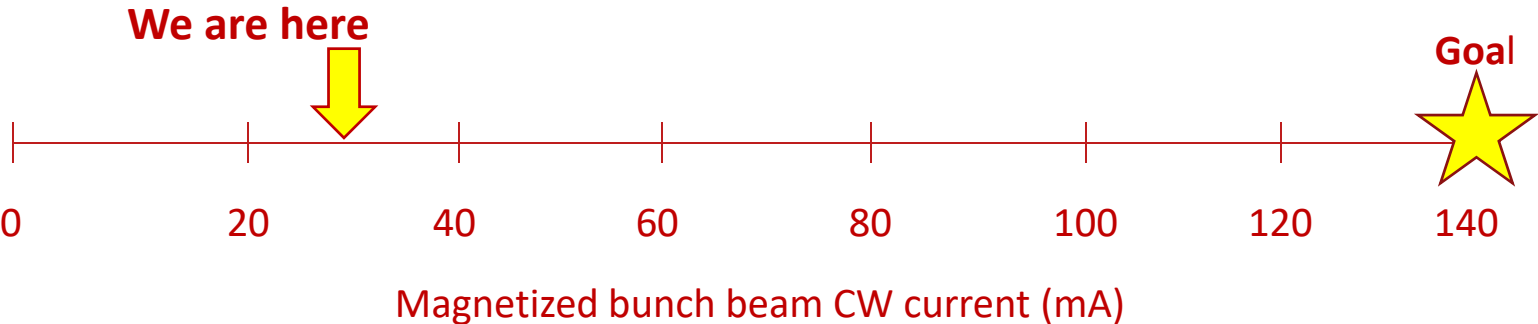
Initial attempts to run high current magnetized beam were limited by gun current surges tripping off the high voltage power supply damaging the photocathode at 1 mA CW



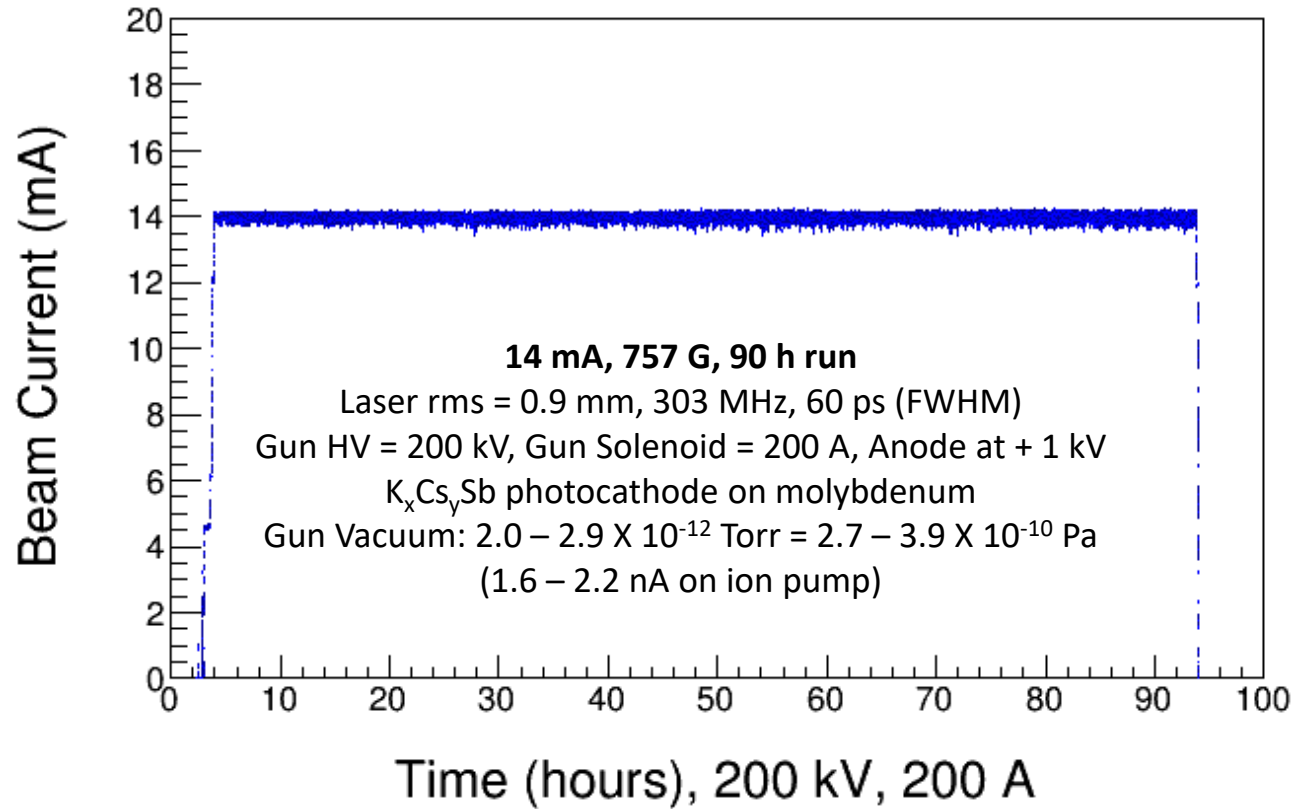
Biasing the gun anode to +1 kVDC was essential to achieve high current magnetized beam for extended periods of time without photocathode arcing



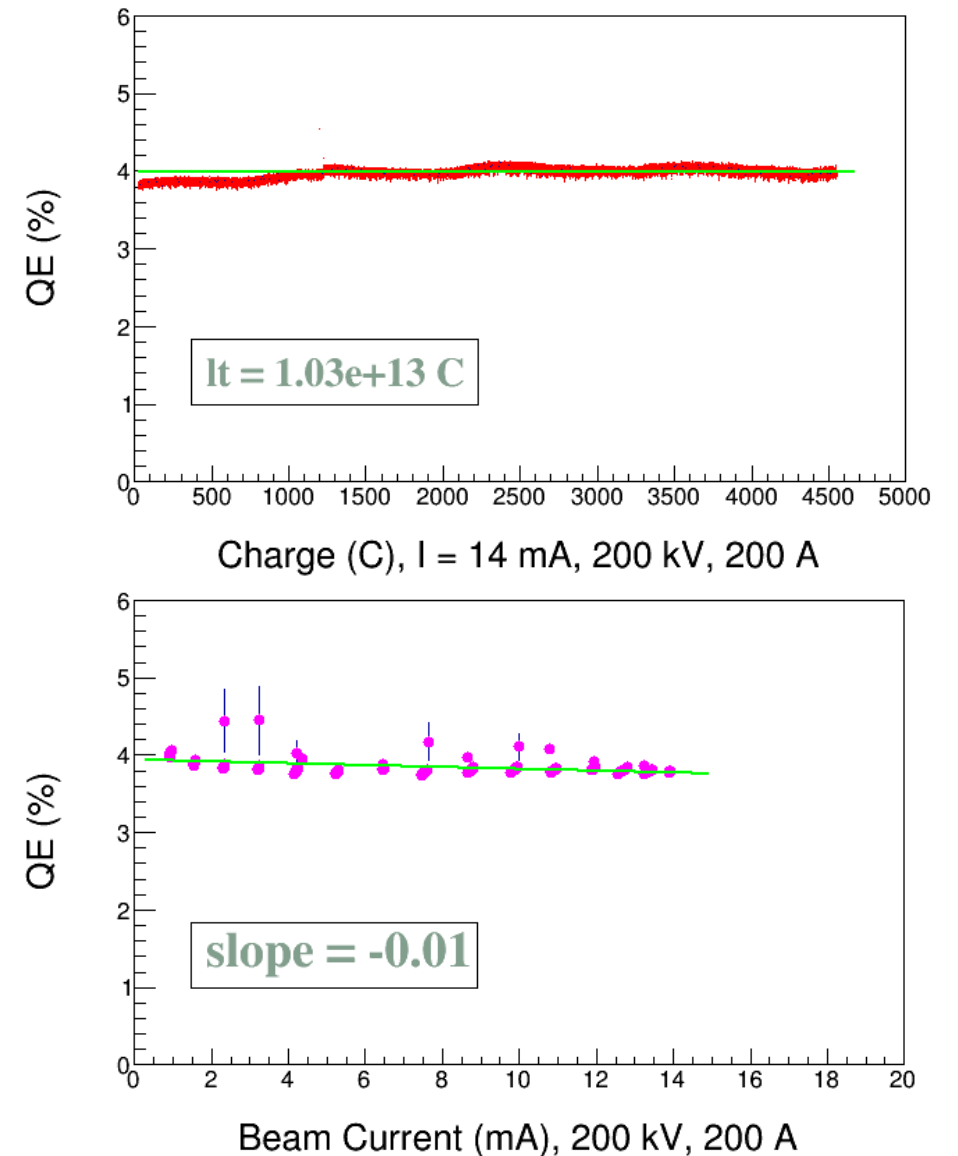
Limited lifetime might be a result of photocathode heating and associated bandgap shift, or ion back bombardment



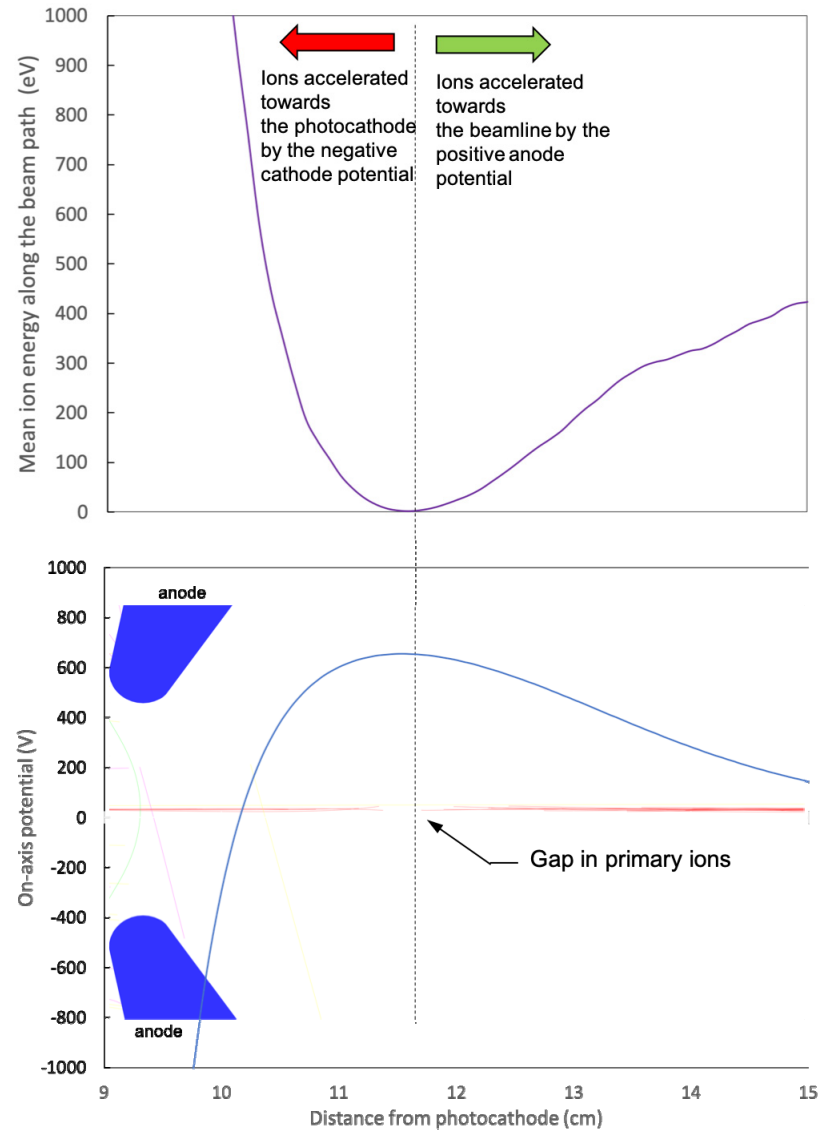
High Current Magnetized Beam: 14 mA at 757 G for 90 h



- No QE degradation over 90 hour run
- Positive anode bias (+1 kV) effectively prevented ions in beamline from reaching the gun that causes micro-arcs and sudden QE degradation

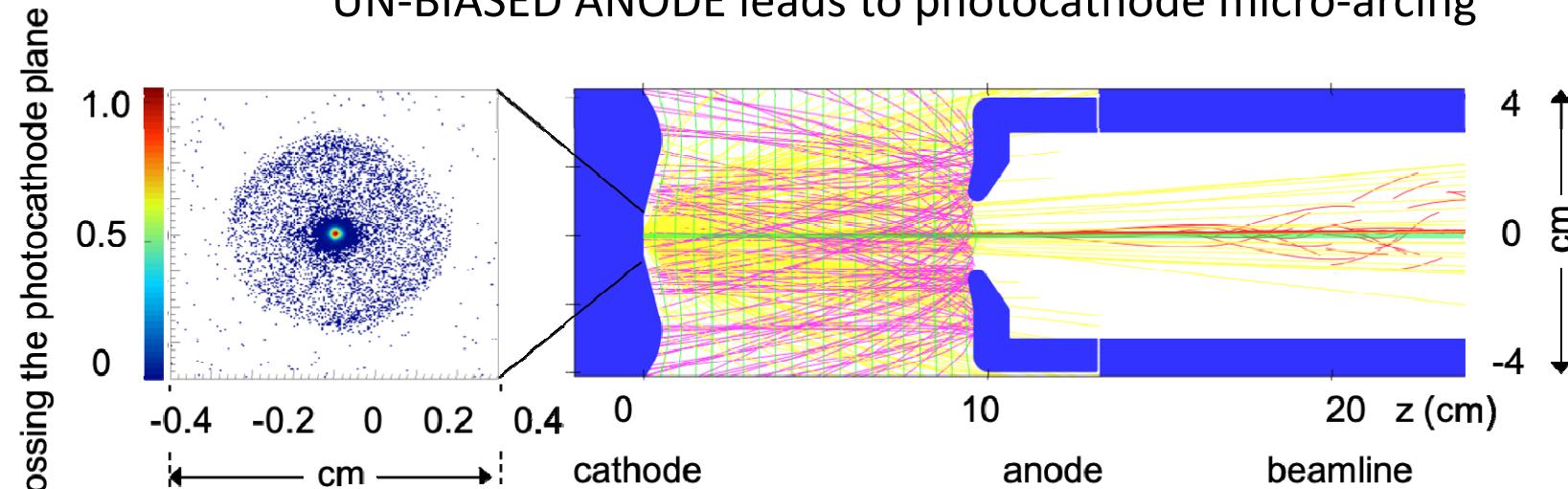


Anode-cathode potential when anode is biased to +1kVDC

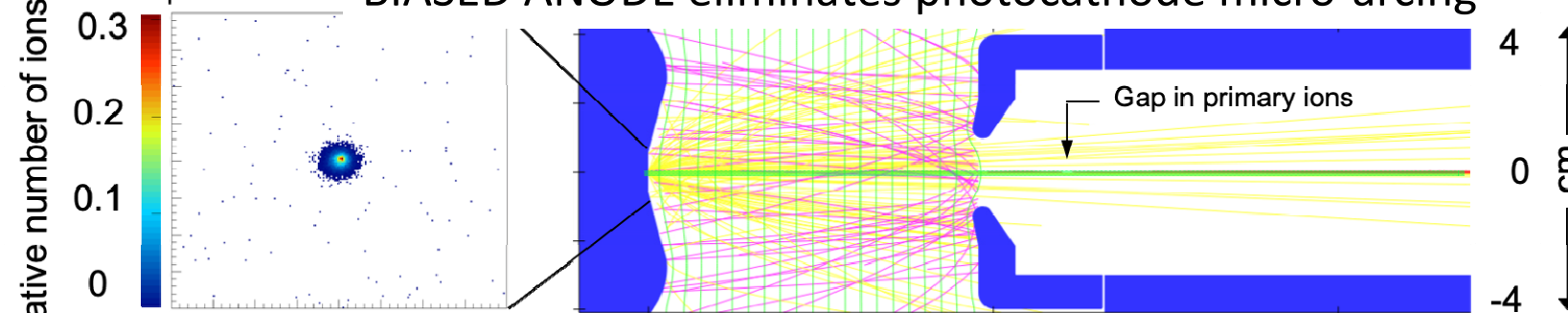


Simulations of ions generated by the high current electron beam suggest that:

UN-BIASED ANODE leads to photocathode micro-arcing



BIASED ANODE eliminates photocathode micro-arcing



The biased anode repels beamline ions allowing to run high current without photocathode arcing

- Ions in the beamline (**red**) are attracted to the potential well formed by the electron beam (**green**)
- These trapped ions are then accelerated towards the negatively biased photocathode where they generate secondary electrons (**yellow**) upon impact which in turn strike the anode and generate secondary ions (**pink**).
- High density 'channels' could form in the anode-cathode gap leading to **arcing** between the **photocathode** and the anode

JLEIC magnetized source beam requirements compared to parameters achieved in this work

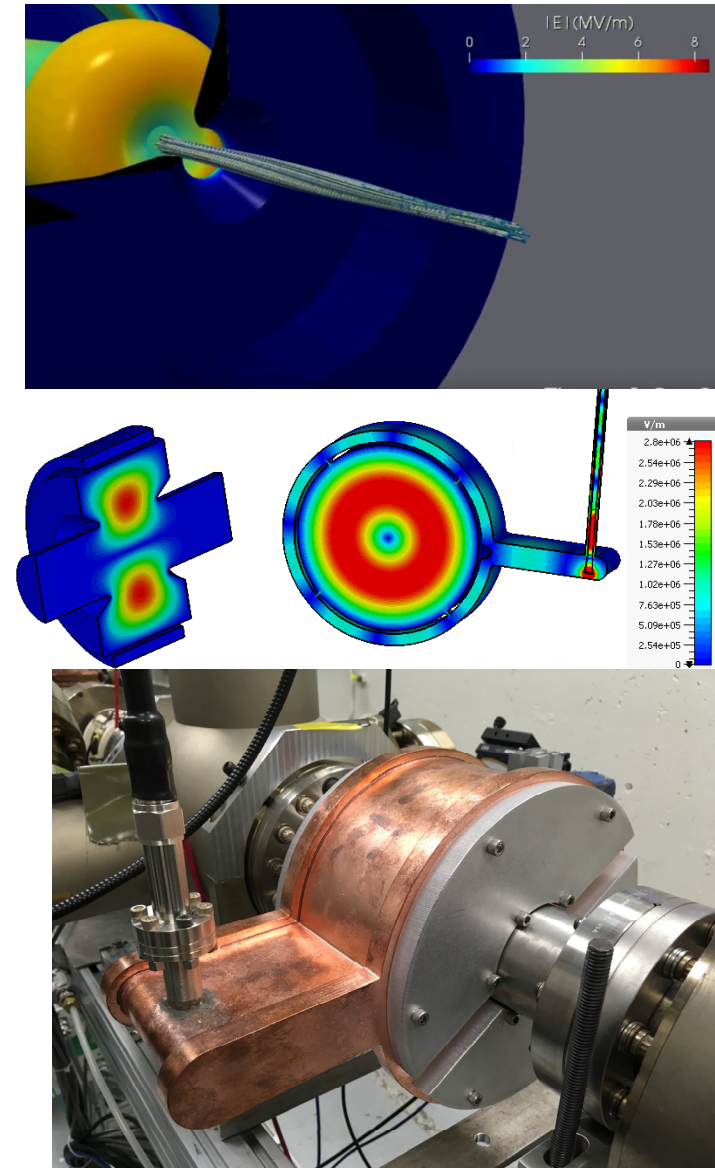
Parameter	JLEIC	Gun Test Stand Demonstrated
Electron bunch length 60 ps (2 cm) Flat-top at cooler injection	60 ps (2 cm)	Gaussian laser pulse 25 – 75 ps FWHM
Repetition rate	43.3 MHz	100 Hz – 374.3 MHz
Bunch charge	3.2 nC	0.7 nC (75 ps FWHM, 25 kHz, 225 kV, 0.76 kG)
Peak current	53.9 A	9.3 A
Average current	140 mA (400 kV)	28 mA (50 ps FWHM, 74.8 pC, 374.25 MHz, 100 kV , 0.57 kG)
Transverse normalized emittance	<10 microns	<2 microns
Normalized drift emittance	36 microns (@3.2 nC)	26 microns (@ 20 femto-Coulomb bunch charge)
Cathode laser spot radius	3.14 mm Flat-top (a_0)	0.9 mm rms (Gaussian)
Solenoid field at cathode (B_z)	0.50 kG	1.51 kG

The beam current was limited by the high voltage power supply
(30 mA/225 kV with 3 kW max power)

Higher gun voltage and longer laser pulse are being explored to achieve required MAGNETIZED bunch charge

Future Plans

- Recently, the photogun has been replaced with the RF-pulsed thermionic gun built by Xelera Research LLC to demonstrate 65 mA magnetized beam (307 G, 500 MHz, 130 pC, 90 ps rms, 125 kV): an SBIR II funded project
- Measure beam magnetization and electron bunch-length for high bunch charge beam with the installed non-invasive magnetometers - TE_{011} Cavity and “Brock” Cavity from Electrodynamics: another SBIR II funded project
- Reinstall photogun, now with Xelera’s power supply and BNL laser (10 MHz), the setup will enable high average current AND high bunch charge, **simultaneously** (30 mA, 3 nC)
- Characterize space-charge effects of high bunch charge and high average current beam as a function of beam magnetization
- Collaborate with Xelera, Electrodynamics, BNL and others on follow-up projects



THANK YOU

On behalf of the JLab magnetized source team!

